

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Nicholas F. Borrelli, Thomas P. Seward III, and
Charlene M. Smith
Appl. No. : 10/039,507
Filed : October 26, 2001
For : SILICA WITH LOW COMPACTION UNDER HIGH
ENERGY IRRADIATION
Examiner : M. Colaianni
Group : 1731

CHANGE OF CORRESPONDENCE ADDRESS

The Zip Code for the correspondence address for the above application has been changed by the U.S. Postal Service from 06430 to 06824.

Please update the Patent Office's records to reflect the new Zip Code. Specifically, the correspondence address should be changed to:

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Respectfully submitted,

Date: 7/14/03

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